



## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q58614

Kenichiro SATO, et al.

Appln. No.: 09/541,597

Group Art Unit: 1752

Confirmation No.: 4840

Examiner: R. ASHTON

Filed: April 03, 2000

POSITIVE PHOTORESIST COMPOSITION FOR FAR UNTRAVIOLET

**EXPOSURE** 

## NOTICE OF APPEAL

Commissioner for Patents Washington, D.C. 20231

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated June 18, 2002.

A check for the statutory fee of \$320.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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